

2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

NISHIMOTO et al

Serial No.: 08/897,839

Filed: July 21, 1997

For: STRESS-ADJUSTED INSULATING  
FILM FORMING METHOD,  
SEMICONDUCTOR DEVICE AND  
METHOD OF MANUFACTURING THE  
SAME



Group Art Unit: 2814

Examiner: K. Eaton

#19  
12/13/00  
CB/DM

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

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DEC 12 2000  
TECHNOLOGY CENTER 2800

It is respectfully requested that the time period for filing a Notice of Appeal in response to the final action of July 5, 2000, initially set to expire October 5, 2000, be extended two months up to and including December 5, 2000. The requisite \$390.00 fee for the requested extension is herewith attached.

Any additional fees may be charged to our Deposit Account No.

12-2174. A duplicate copy of this sheet is attached.

12/06/2000 MBERHE 00000081 08897839

01 FC:116

390.00 OP

Respectfully submitted,

George A. Loud  
Reg. No. 25,814

Dated: December 5, 2000

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